

AMENDMENTS TO THE CLAIMS

1. (currently amended) A method of performing digital optical communications to transmit an optical signal through an optical fiber, comprising ~~the step of~~:
shaping ~~the a~~ waveform of the optical signal ~~to be being~~ transmitted through the optical fiber ~~to increase by increasing~~ by increasing the frequency thereof before the ~~waveform power~~ is stabilized, when the optical signal starts increasing in level at ~~the a~~ time the optical signal is applied to the optical fiber.

2. (currently amended) A semiconductor laser that modulates from a first level to a second level, comprising:

a diffraction grating for effecting distribution feedback, said diffraction grating having a normalized coupling coefficient kL of at least 2.0, said diffraction grating having a phase shift region disposed therein for achieving a phase shift of at most $\lambda/4$; and

an active layer having including a multiple quantum well structure, having a gain which saturation coefficient of greater than 0, such that said gain is saturated as a carrier concentration in the active layer increases.

3. (original) A semiconductor laser according to claim 2, further comprising a resonator, said phase shift region being disposed nearly centrally in said resonator.

4. (currently amended) A semiconductor laser according to claim 2, comprising:
a diffraction grating for effecting distribution feedback, said diffraction grating having a normalized coupling coefficient kL of at least 2.0, said diffraction grating having a phase shift region disposed therein for achieving a phase shift of at most $\lambda/4$; and

an active layer including a gain, which is saturated as a carrier concentration in the active layer increases,

wherein said active layer has includes a multiple quantum well structure having growth surface irregularities.

5. (currently amended) A semiconductor laser according to claim 3, comprising:

a diffraction grating for effecting distribution feedback, said diffraction grating having a normalized coupling coefficient kL of at least 2.0, said diffraction grating having a phase shift region disposed therein for achieving a phase shift of at most $\lambda/4$;

an active layer including a gain, which is saturated as a carrier concentration in the active layer increases; and

a resonator, said phase shift region being disposed nearly centrally in said resonator,

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wherein said active layer has includes a multiple quantum well structure having growth surface irregularities.

6. (currently amended) A semiconductor laser according to claim 2, comprising:
a diffraction grating for effecting distribution feedback, said diffraction grating having a normalized coupling coefficient kL of at least 2.0, said diffraction grating having a phase shift region disposed therein for achieving a phase shift of at most $\lambda/4$; and
an active layer including a gain, which is saturated as a carrier concentration in the active layer increases,
wherein said active layer has includes a multiple quantum well structure composed of comprising two stage potential quantum wells.

7. (currently amended) A semiconductor laser according to claim 3, comprising:
a diffraction grating for effecting distribution feedback, said diffraction grating having a normalized coupling coefficient kL of at least 2.0, said diffraction grating having a phase shift region disposed therein for achieving a phase shift of at most $\lambda/4$;
an active layer including a gain, which is saturated as a carrier concentration in the active layer increases; and
a resonator, said phase shift region being disposed nearly centrally in said resonator,
wherein said active layer has includes a multiple quantum well structure composed of comprising two stage potential quantum wells.

8. (currently amended) A semiconductor laser according to claim 2, comprising:
a diffraction grating for effecting distribution feedback, said diffraction grating having a normalized coupling coefficient kL of at least 2.0, said diffraction grating having a phase

shift region disposed therein for achieving a phase shift of at most $\lambda/4$; and
an active layer including a gain, which is saturated as a carrier concentration in the
active layer increases,

wherein said active layer has includes a multiple quantum well structure
including a non-radiative carrier recombination layer.

9. (currently amended) A semiconductor laser according to claim 3, comprising:
a diffraction grating for effecting distribution feedback, said diffraction grating having
a normalized coupling coefficient kL of at least 2.0, said diffraction grating having a phase
shift region disposed therein for achieving a phase shift of at most $\lambda/4$;

an active layer including a gain, which is saturated as a carrier concentration in the
active layer increases; and

a resonator, said phase shift region being disposed nearly centrally in said resonator,

wherein said active layer has includes a multiple quantum well structure
including a non-radiative carrier recombination layer.

10. (currently amended) A semiconductor laser according to claim 2, comprising:
a diffraction grating for effecting distribution feedback, said diffraction grating having
a normalized coupling coefficient kL of at least 2.0, said diffraction grating having a phase
shift region disposed therein for achieving a phase shift of at most $\lambda/4$; and

an active layer including a gain, which is saturated as a carrier concentration in the
active layer increases,

wherein said active layer has includes a multiple quantum well structure which
is progressively thicker toward the center of the semiconductor laser in the axial direction of
the resonator.

11. (currently amended) A semiconductor laser according to claim 3, comprising:
a diffraction grating for effecting distribution feedback, said diffraction grating having
a normalized coupling coefficient kL of at least 2.0, said diffraction grating having a phase
shift region disposed therein for achieving a phase shift of at most $\lambda/4$;

an active layer including a gain, which is saturated as a carrier concentration in the

active layer increases; and

a resonator, said phase shift region being disposed nearly centrally in said resonator,

wherein said active layer ~~has~~ includes a multiple quantum well structure which is progressively thicker toward the center of the semiconductor laser in the axial direction of the resonator.

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12. (original) A digital optical communication system comprising a semiconductor laser according to claim 2 as a communication light source.

13. (original) A digital optical communication system comprising a semiconductor laser according to claim 3 as a communication light source.

14. (new) A method of transmitting an optical signal through an optical fiber, comprising: modulating from a first level to a second level, a semiconductor laser; and after said modulating, increasing a frequency, f , of a relaxation oscillation, such that, $df/dt > 0$.

15. (new) A method of transmitting an optical signal through an optical fiber, comprising: modulating, from a first to a second level, a semiconductor laser; and after said modulating, providing an optical signal with a frequency, f , such that a magnitude of a stabilized state exceeds that of a local stabilized state during said modulating to produce a pulse compression.